

New production technologies for printed electronics



23/05/2024

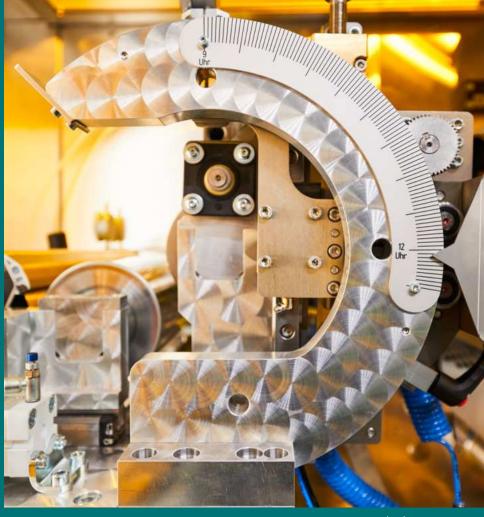
Agenda

- 1. Introduction
- 2. The printed electronics market
- 3. Bridging the gap
- 4. Technologies & processes
- 5. Slot die for printed electronics
- 6. Printing processes
- 7. Nanoimprint
- 8. Drying
- 9. SALD
- 10.Summary



1.

Introduction



Introduction



Overview





Group of companies



ALTONAER TECHNOLOGIE HOLDING



- ✓ Founded 1903
- ✓ Approx. 200 employees
- ✓ Located in Hamburg

DRYTEC

- ✓ Founded 1995
- ✓ Approx. 50 employees
- ✓ Located in Norderstedt



- ✓ Founded 1974
- ✓ Approx. 50 employees
- ✓ Located in Dormagen

Introduction



Coatema equipment platform strategy for lab2fab



- ✓ State-of-the-art research and development equipment
- ✓ Sheet-to-sheet to roll-to-roll systems on smale scale & footprint





- Proven processes for printing, coating and laminating equipment
- ✓ Highest-quality pilot lines enable stable pilot production and reduce cost of operation
- Scaling laboratory equipment to enable pilot production

✓ Full-scale production lines

Production

Optimize the manufacturing process, including streamlining assembly, reducing material waste, and optimizing the carbon footprint



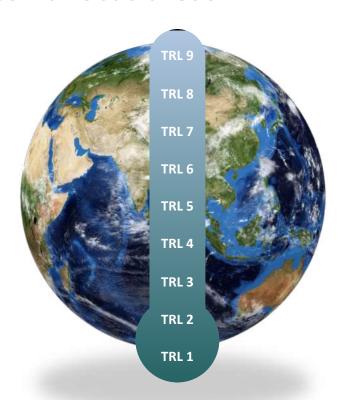
Our markets – Coatema focus areas

Green Hydrogen

Fuel cells

Batteries

Solar



Sustainability

Digital fabrication

Printed electronics

The next thing



R&D centre USP









Process development

- Feasibility study
- Ink process study
- **Process analysis**
- Slot die coating simulations
- Proof of concept

TRL evaluation

✓ Small scale prototype



Test production

- Prototyping
- Training of staff Near to market testing



Education

- Coating conference
 - **Education of students**
 - Partner trainings Workforce training



Development of custom-made design for equipment

Prototyping

Proof of concept



Public funded research projects know-how

- German funded
- ✓ Global 2+2 projects

Horizon 2020

B2B projects

Introduction – R&D centre















R&D customers







































































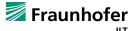
Fraunhofer



Fraunhofer

















Hochschule Reutlingen

Reutlingen University







23/05/2024

MEMBER OF ATH

Our markets



R&D projects overview 2022 – 2024



In-line and real-time digital nanocharacterization for flexible organic electronics

NOUVEAU PROJECT

The NOUVEAU project will develop solid oxide cells (SOCs) with innovative La- and PMG-free electrode materials





R2R production line for OPV solar with integrated backend



Development of near-field electro hydrodynamic nanowire printing





Implementation of laser drying processes for lithium-ion battery production



R2R process optimization for solid state batteries





Plasmonically enhanced photocatalysis for wastewater treatment

RetroWin

R2R Process and machinery development for retrofit window films for lower production costs





The WaterProof project aims at developing an electrochemical process that converts CO₂ emission



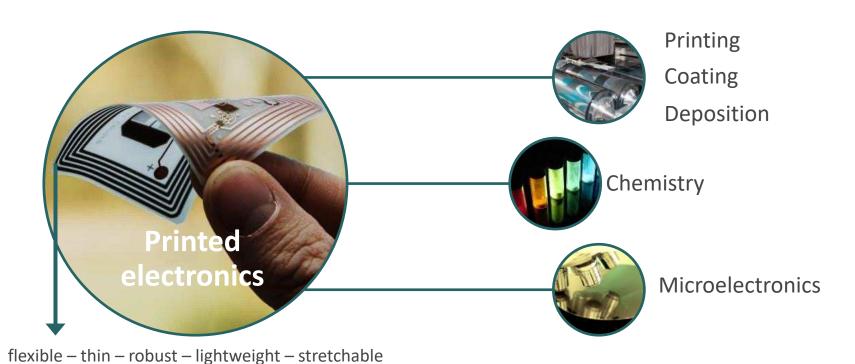
Creating an openinnovation testbed for sustainable packaging 2.

The printed electronics market



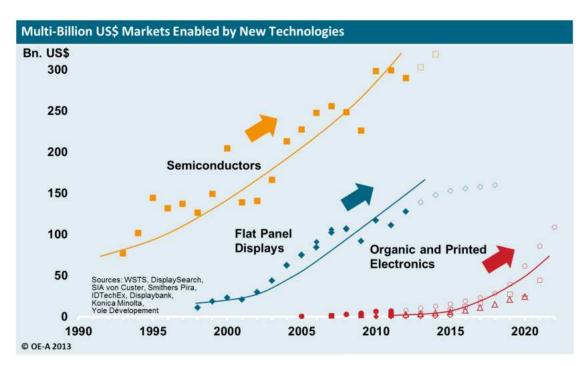








The future market



2010

2 Billion US\$ predominantly by OLED displays

2012

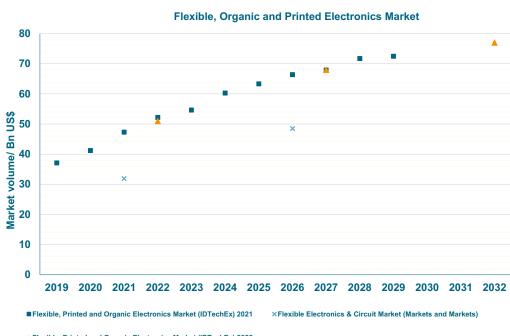
8 Billion US\$ predominantly by OLED displays

Potential

for a 50 Billion US\$ market within the next 10 years driven by OPV, lighting, displays, logic, memory/RFID, sensors







▲ Flexible, Printed and Organic Electronics Market (IDTechEx) 2022

Flexible, organic and printed electronics enables new applications and opens new markets

50+ Bn US\$ Market today, OLEDs, sensors, medtech

Large Potential driven by displays, sensors, wearables, OPV, lighting, RFID/NFC











Flexible, organic and printed electronics solutions in important industry sectors

Automotive

OLED lighting for rear lights, ambient lighting by hybrid electronics, printed (radar) antennas, seat occupancy detection, seamless integration of touch sensors, smart HMI functions, integrated heating foils



Printing & Packaging Automated stock replenishment system, large area capacitive sensor floor, thin film encapsulation for OLED. RFID, NFC, flexible batteries, smart packaging for food and medical with time and temperature tracking, light emitting packaging (EL, OLED), non-light-emitting technology (EPD,



Consumer **Electronics**

Foldable & flexible displays for smart phones / tablets / wearables: Curved touch surfaces with sensing & signage for white goods; smart wearables and textiles; smart patches for sports tracking, OLED lighting; printed Batteries, printed QD layers in TVs. Printed OLED TVs and Monitors



Smart Buildings Sensors for material monitoring, energy management (climate, smart windows) and wellbeing (humidity, gas); energy autonomous sensors; Heating and touch elements; BIOPV: OLED lighting, OPV on walls



Healthcare

Smart medical packages for therapy monitoring; textiles with embedded pressure sensors, temperature/ humidity sensors, continuous real-time heart monitoring, patches for therapy and vital parameter monitoring; sensors for on - and off-body biomarker diagnosis; smart wound treatment and bandages; Sensors for medical applications (Blood -Glucose-Test, intelligent incontinence solution), pressure sensor (Dental occlusion measurement films



Internet of Things

Connected home appliances, autonomous cars and smart wearables, precision agriculture, environmental monitoring, Supply chain management with item level tagging, data loggers for containers, voyage optimization



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Forecast for market entry of OPE applications

Short, medium and long term forecasts for key industry sectors:

- ✓ Automotive
- ✓ Consumer Electronics
- ✓ Healthcare
- ✓ Printing & Packaging
- ✓ Smart Buildings
- ✓ Internet of Things

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The future market – Key trends



















Digital fabrication as a trend in PE







Digital fabrication is happening

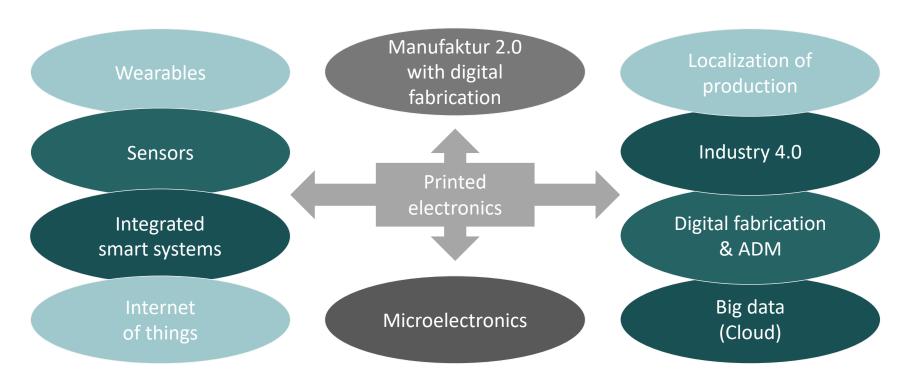
lot size 1 is real.

Why now?

Digital fabrication and additive manufacturing will disruptively change the world of manufacturing we know today!



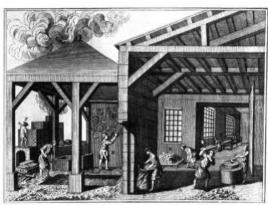
Disruptive!





The "4th" industrial revolution

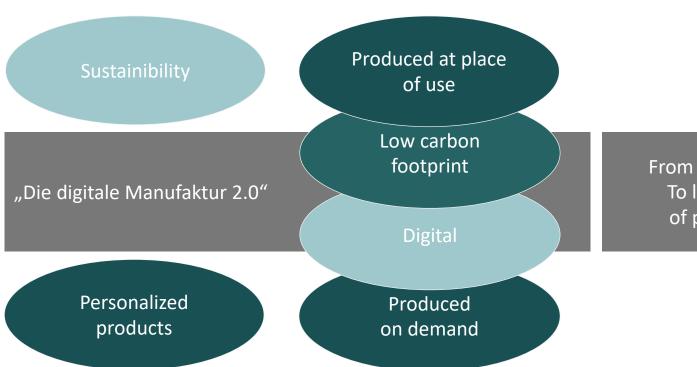
- ✓ Digital fabrication means to have the abillity to produce lot size one for the same cost as for lot size million.
- Manufacturing at the site with personalized design for each customer.
- ✓ It will change global manufacturing to local manufacturing.
- ✓ Productivity boost for the old economies and Europe, the real 4th revolution.
- ✓ The "Manufaktur" will come back as the "digitale Manufaktur 2.0".







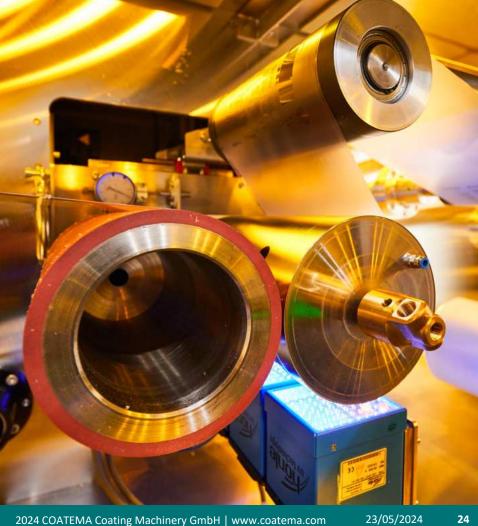
Disruptive



From globalization
To localization
of production

3.

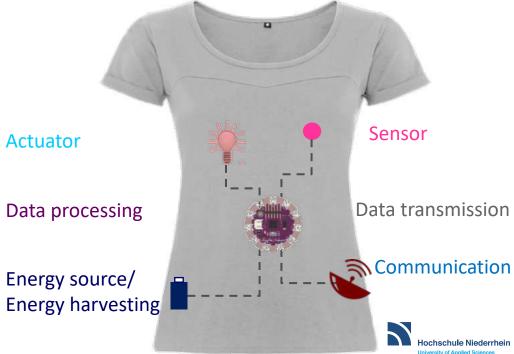
Bridging the gap





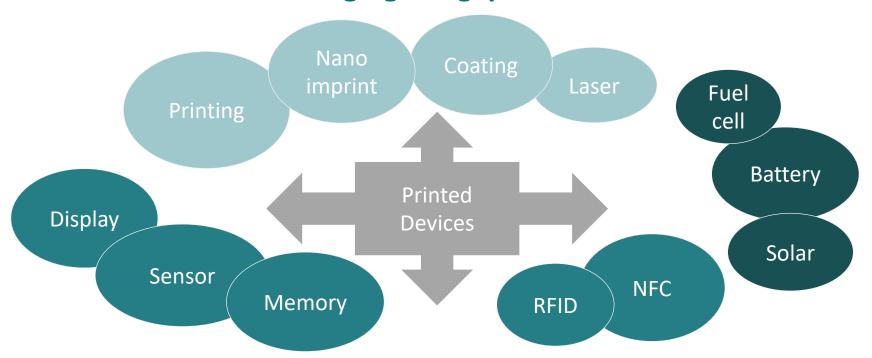
From 2008 till today – PE as the flexible bridge







Printed electronics – bridging the gap

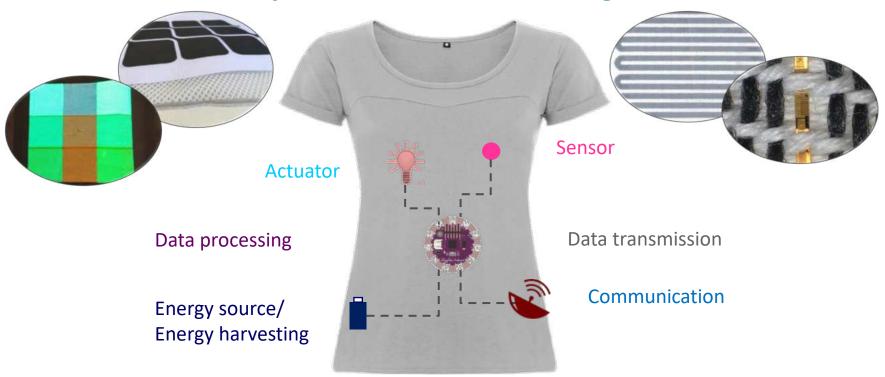


What could be the pathway on to textiles or also integrated into textiles?





From 2008 till today – PE as the flexible bridge



Bridging the gap



Case study – design principles

Authors: Juha-Veikko Voutilainen, Tuomas Happonen, University of Oulu

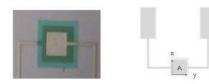


Figure 1. Printed temperature sensor and layout

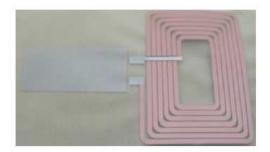


Figure 2. A remote readable RH sensor.

Authors: Tuomas Happonen, Juha-Veikko Voutilainen, University of Oulu

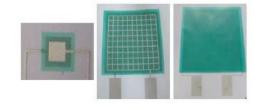




Figure 1. Printed capacitive humidity sensor structures

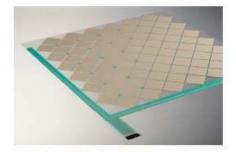


Figure 1. Capacitive touch sensor



Figure 1. Electrochemical biosensor

Authors: Elina Jansson, Jukka Hast, VTT



Figure 1. Printed gas sensors



Designer's Handbook 2014

4.

Technologies & processes



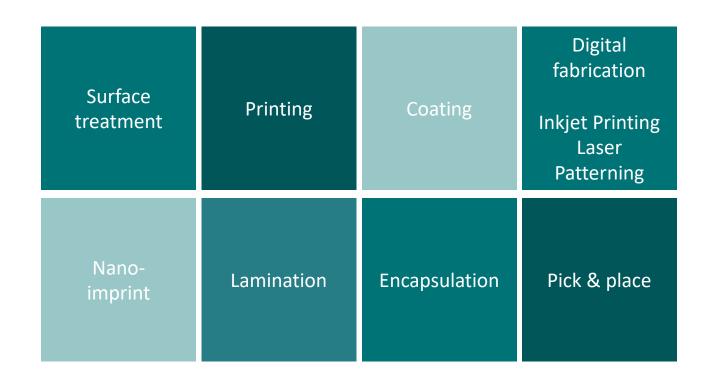


Coating parameters

Coating chemistry	Coating processes	Process control	Drying
 Rheology Viscosity Viscoelasticity Type of solvents Solid content Van der Waals force Sheer ratio Adhesion/Cohesion 	 ✓ Coating systems ✓ Single or multilayer coatings ✓ Direct coatings ✓ Transfer (indirect) coatings ✓ Substrate speed ✓ Layer thickness ✓ Coating accuracy 	 Process layout Tension control system Material guiding system Inline parameter control Quality control 	 Convection drying Contact drying Infrared drying Sintering NIR High frequency UV crosslinking systems
Substrate	Pretreatment	Environment	Finishing
✓ Surface tension✓ Dimension stability✓ Surface structure✓ Contact angle	✓ Corona✓ Plasma✓ Cleaning	HumidityTemperatureInert conditions	✓ Calendaring✓ Embossing✓ Slitting



Processes





Upscaling from lab 2 fab – going to fab-technologies



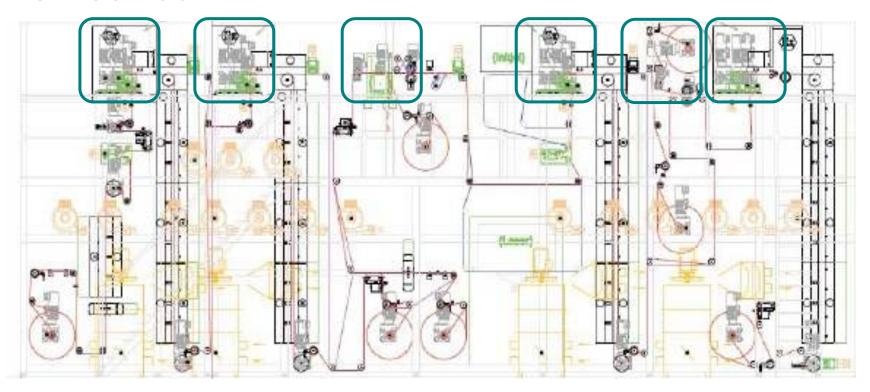






From lab 2 fab







Process parameters

Process parameters are:

- Operation speed
- Rheology of coating and printing inks
- ✓ Substrate condition
- ✓ Tension control MD / CD
- Edge control
- Resolution and registration accuracy of printing / laminating systems
- Precision of coating operations
- Curing / drying / crosslinking



Inline process integration

Tension control

- ✓ Load cell
- ✓ Dancer
- ✓ Pulling devices
- ✓ Design of drives

Registration control

- ✓ Camera
- ✓ Fiber optic
- ✓ Design of drives
- ✓ Algorithm control

Edge guide control

- ✓ Different sensors
- ✓ Mechanical stress

Process analysis

- ✓ Statistic parameters
- ✓ Product flow analysis
- ✓ Yield
- ✓ Cost of ownership
- ✓ Artificial inteligence

Quality control

- ✓ Particle contamination analysis
- ✓ Defect detection
- ✓ Thickness control
- ✓ Function control of the device or layer
- ✓ Big data (Cloud)
- ✓ Artificial inteligence





Inline process integration and measuring points

Winder speed / Diameter / Cross position / tension / particle contermination / substrate defects / registration marks





Unwinder OET 4 Axis system

3m dryers

ps laser

OET 4 Axis Ink jet system

3m dryers

IPL optical

In-line

LBIC Rewinder

Number of measuring points

Amount of measurements per time





Winding / cleaning



Unwinding cabinet

- ✓ Can receive rolls with core of 3 inch
- ✓ Max diameter of 500 mm
- ✓ Max weight 50 kg
- ✓ Web width of 300 mm
- ✓ Automated forward and reverse movement of the web
- ✓ Speed of 1 20 m/min.
- ✓ Tension control of the web within the range of 5 250 N

Web cleaning system

✓ Contact cleaning rollers for particles of >1µm diameter





Inline process integration





1st Printing

✓ Web surface activation with Plasma Treatment

Dryer 1

- √ 3 meter dryers
- ✓ Hot air and heated nitrogen
- ✓ Temperatures up to 230 °C



Slot die coating





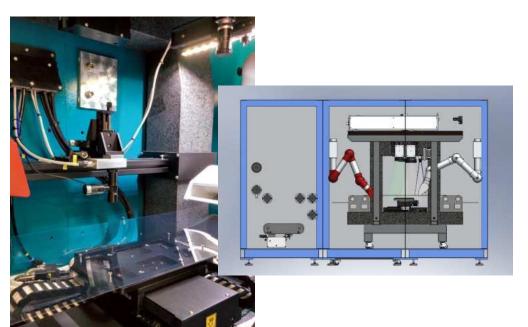
Slot die coating station compatible for materials used in OEs

- ✓ Print solutions with viscosity range of 10 – 1000 mPas
- ✓ The above range can lead to layer thickness range of 10 – 1000 nm
- ✓ Lateral accuracy of ±1%





Laser patterning



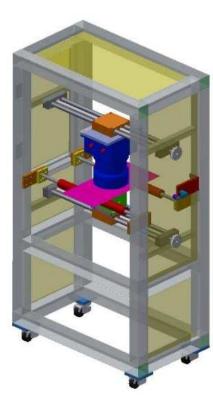
Laser scribing/patterning

- ✓ Picosecond laser for patterning OE materials
- ✓ 3 meters cabinets
- ✓ Tension and driving web control
- ✓ System ±100 µm of accuracy



Module for the registration camera





Technical specifications:

- ✓ Measurement accuracy = +/-20 µm
- ✓ ATEX proof
- √ 300 mm roller width
- ✓ Web speed: 1 – 20 m/min; Optimum speed is 3 – 20 m/min.
- ✓ PLC-driven correction adjustment system
- ✓ Module to be operated under N₂



Rotary screen printing



2nd printing station

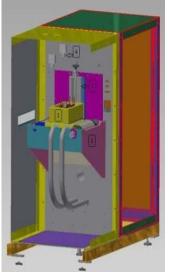
- ✓ Rotary screen printing
- ✓ Coating width of 300mm
- ✓ Lateral accuracy ±5%

Dryer 2

- √ 3 meters dryers
- ✓ Hot air and heated nitrogen
- ✓ Temperatures up to 230°C



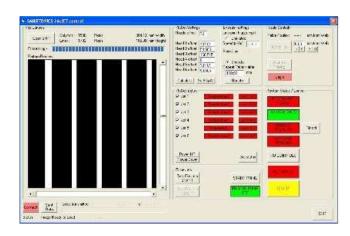
Inline process integration







Coatema software



Already integrated: Fujifilm Dimatix



Encapsulation



Rewinding station

- ✓ The rewinding station has a retaining roller
- ✓ Identical specs to the unwinding station
 - √ 3 inch core rolls
 - Automated forward and reverse movement of the web
 - ✓ Speed of 1 20 m/min.
 - ✓ Tension control and edge guide system

Lamination / delamination station

- ✓ Compatible with 300 mm web width
- ✓ Web control with edge guide system
- ✓ Lateral accuracy of ±100 μm / 20 μm





Inline quality control – Ellipsiometry and inline Raman by Horiba











Summary

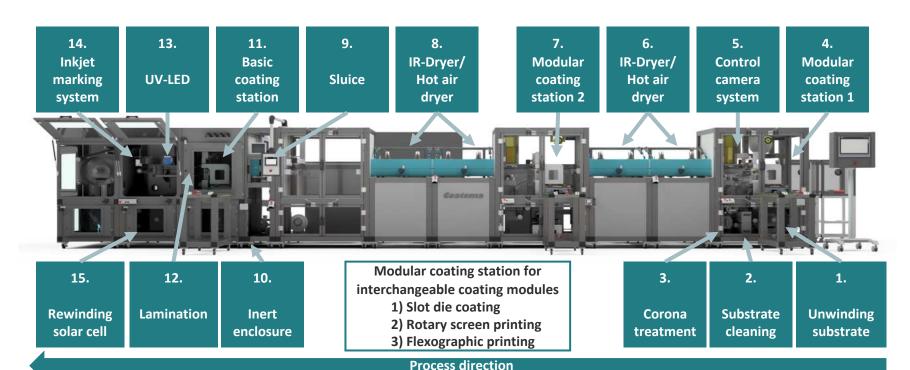


- ✓ 19 m in length
- ✓ 300 mm working width
- √ 30 m/min production speed
- 3 print stations
- ✓ Plasma treatment
- ✓ 6.000 mm dryers

- Registration control
- ✓ Laminating station
- ✓ 36 measuring points
- 3 quality control systems
- How many data points in one 7h shift?



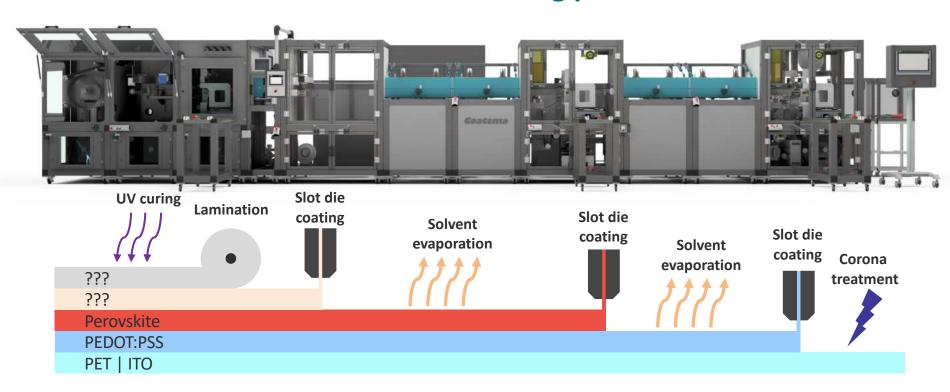
Coatema Perovskite PV Manufacturing plant − Click&CoatTM



Coatema equipment platform strategy



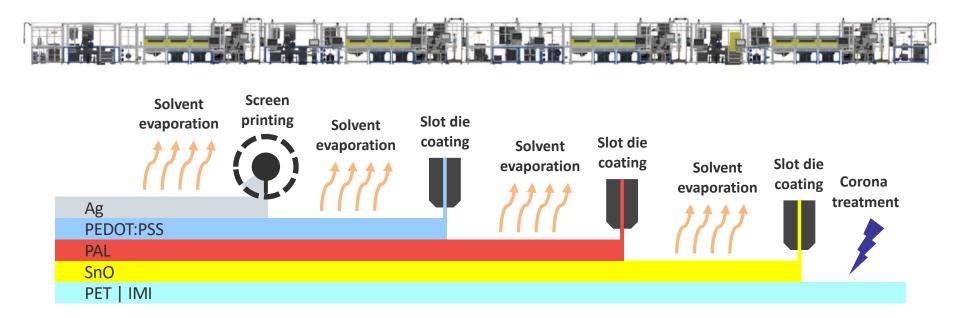
Coatema Perovskite PV Manufacturing plant − Click&CoatTM



Coatema OPV PV Manufacturing plant – Click&Coat







5.

Slot die for printed electronics







Slot die



Coating parameters

Ink properties	Coating processes	Process control	Drying
 ✓ Rheology ✓ Viscosity ✓ Viscoelasticity ✓ Type of solvents ✓ Solid content ✓ Van der Waals force ✓ Sheer ratio ✓ Adhesion/Cohesion 	 ✓ Coating systems ✓ Single or multilayer coatings ✓ Direct coatings ✓ Transfer (indirect) coatings ✓ Substrate speed ✓ Layer thickness ✓ Coating accuracy 	 Process layout Tension control system Material guiding system Inline parameter control Quality control 	 Convection drying Contact drying Infrared drying Sintering NIR High frequency UV crosslinking systems
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Slot die



Coating systems

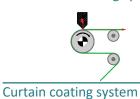




Knife system

Slot die system

Double side coating system



Commabar system



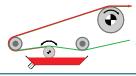
Reverse commabar system



Case knife system



Rotary screen system



Dipping system (Foulard)

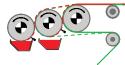


Powder scattering system



Reverse roll coating system







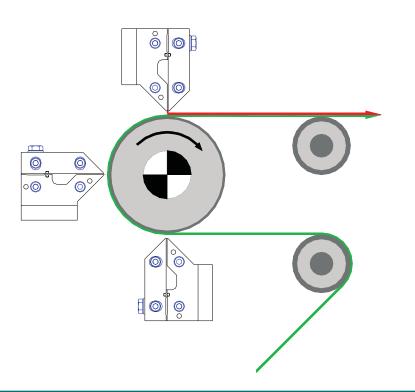
2-roller coating system

3-roller combi coating system

5-roller coating system



Basics of slot die coating – range of parameters



Coating speed

✓ 0.1 - >1000 m/min

Ink viscosity

 $\sqrt{1-300\,000}$ mPas

Layer thickness (dry)

√ 0.1 - >200 µm

Coating accuracy

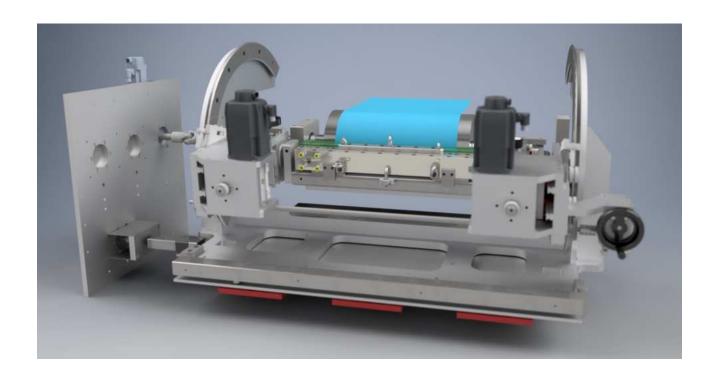
<1% (2 − 5%)

Coating width

✓ up to approx. 3 m

Slot die coating

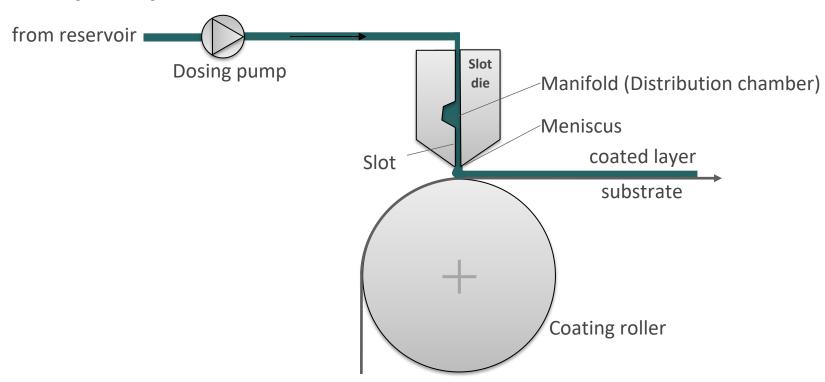








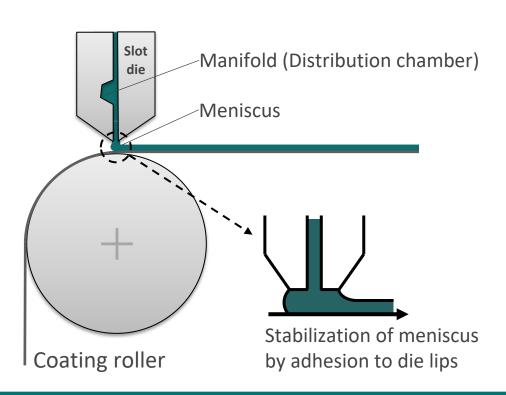




Slot die coating

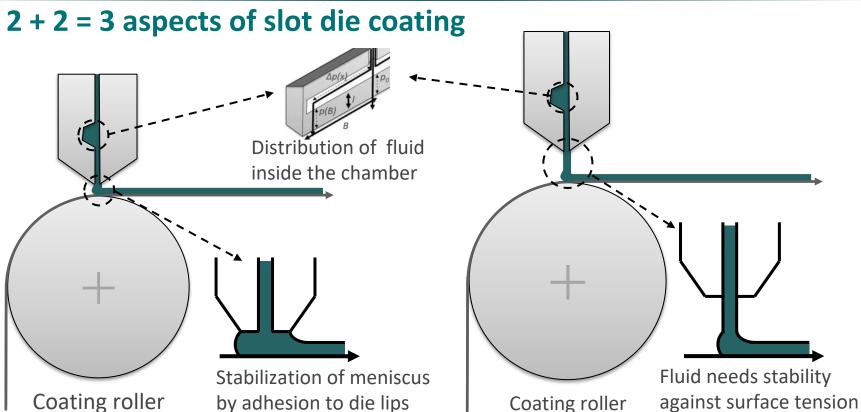


Bead mode



- Meniscus is formed between die lips and substrate
- Adhesive stabilization of meniscus by die lips
- ✓ Very low minimum flow rate possible
- ✓ For a stable process the range of rheological parameters is limited
- ✓ Preferrably for low coating speed





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Theoretical background – "Basic" fluid dynamics for advances geometries

$$\oint \rho v dA = 0$$

Continuity equation (conservation of mass)

Any flow of liquids is described by a set of differential equations:

To describe the meniscus flow of a slot die means, to solve these differential equations for given boundary conditions.

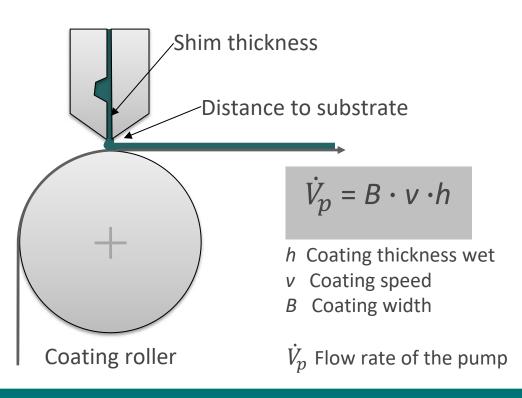
Can be done by appropriate computer programs.

$$\frac{\partial v}{\partial t} + (v\nabla) v = \frac{(-\nabla p + \eta \Delta v + f)}{\rho}$$

Navier-Stokes-equations (equations of motion for incompressible fluids, ρ = const) Δ , ∇ = differential operators



Theoretical background

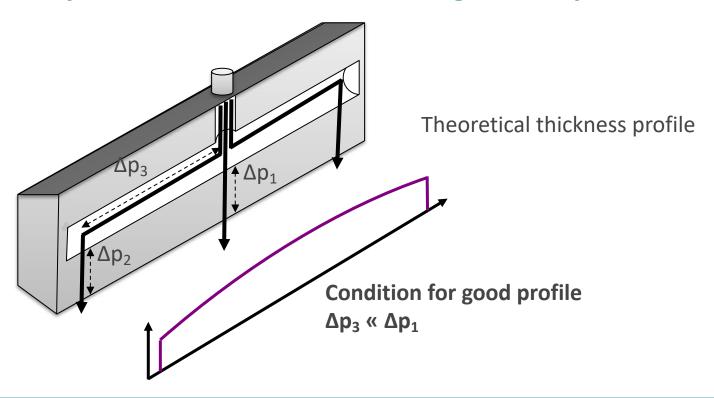


Contrary to a widespread misunderstanding the wet coating thickness does not depend on the shim thickness.

Shim thickness and distance to substrate only help to stabilize the meniscus.

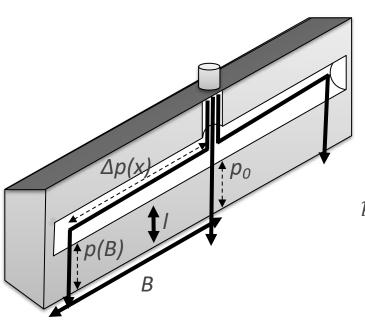


Why should a slot die coat homogeneously?





Fluids in the manifold: 1.5D approximation



Pressure drop $\Delta p(x)$ via pumping through finitely sized distribution chamber leads to:

Theoretical pressure Theoretical thickness

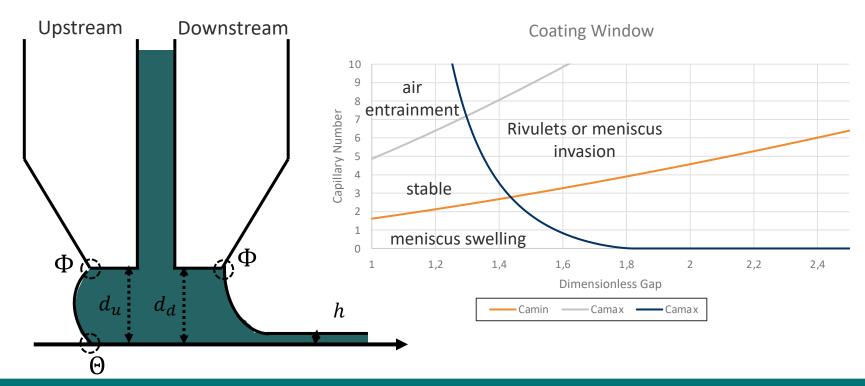
profile:
$$p(x) = p_0 \cdot \frac{\cosh \frac{W - x}{\lambda}}{\cosh \frac{W}{\lambda}} \qquad h(x) = \frac{B \cdot h_0}{\lambda} \cdot \frac{\cosh \frac{W - x}{\lambda}}{\sinh \frac{W}{\lambda}}$$

$$h(x) = \frac{B \cdot h_0}{\lambda} \cdot \frac{\cosh \frac{W - x}{\lambda}}{\sinh W}$$

$$\lambda = \sqrt{\frac{3\pi \cdot l \cdot r^4}{2\delta^3}}$$
 "slot die geometry parameter"



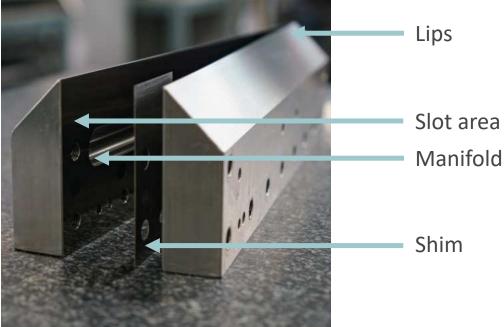
Calculation of the meniscus stability





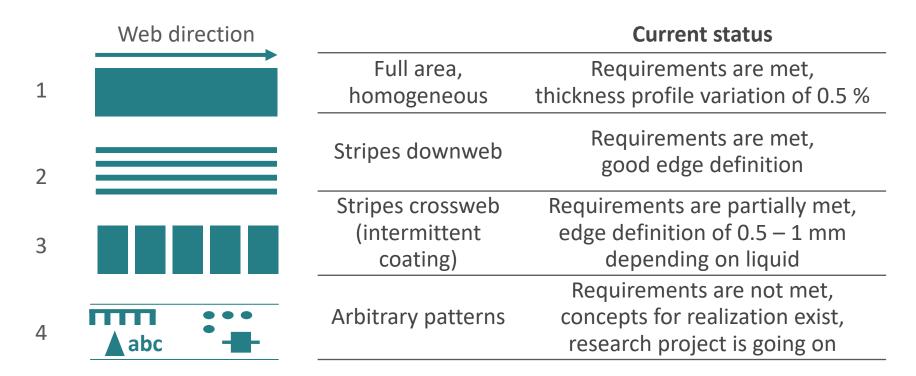
Coatema standard layout – one design among many available



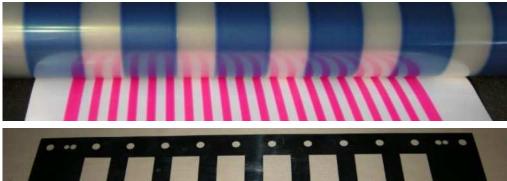




Structured coating – levels of complexity







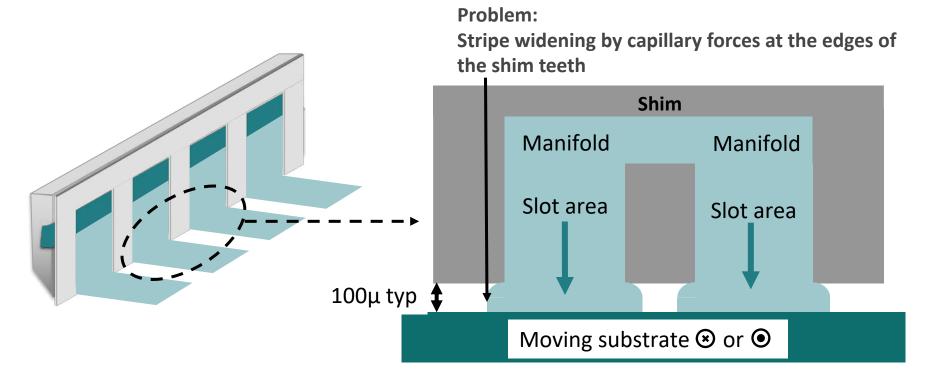
Downweb stripes of different width ...



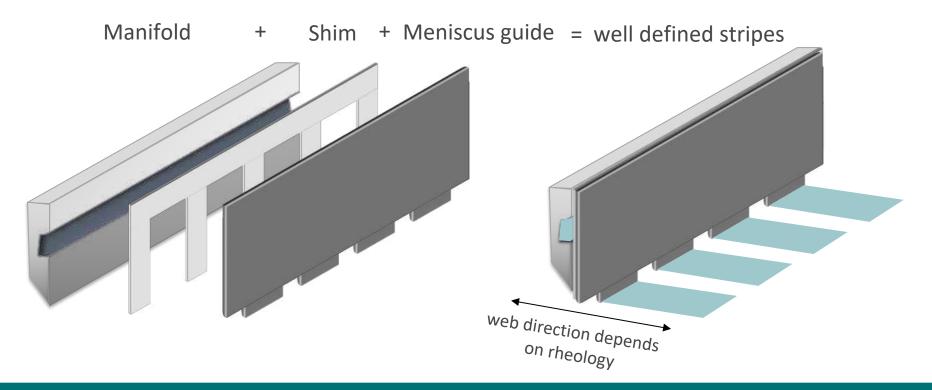
... are made by appropriate shims, lasercut from steel or kapton













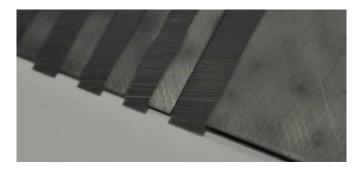


Meniscus guide

Shim



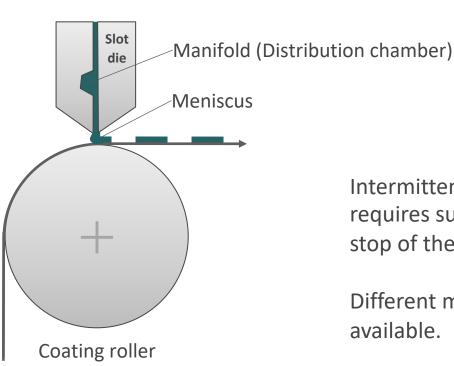
Meniscus guide + shim





Structured coating – crossweb stripes (intermittent)





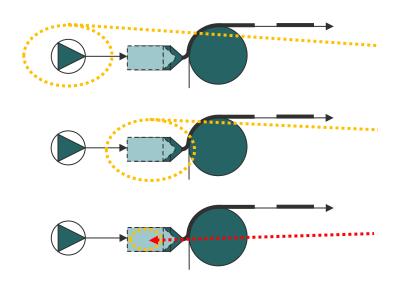
Intermittent coating requires sudden start / stop of the fluid flow.

Different methods are available.

Slot die coating



Standard techniques for intermittent coating



Pump:

stop – reverse – restart

Slot die body:

move back – move forth to minimum gap – move back to working gap (wedge procedure)

Slot die internal:

stop and redirect the flow by shutters and valves. Pump flow continues, die flow stops.

All 3 techniques (single or in combination) work quite well, if the viscosity is rather high and the required edge defintion is not more precise than around 1 mm. All techniques may be combined with a vacuum pump upstream to stabilize the meniscus and suck away residual liquid.

Slot die coating



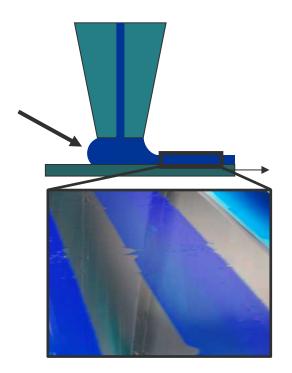
Structured coating – reason for bad edges at low viscosity

- Mensicus has to be interrupted
- ✓ Low viscous liquids do not break along a straight line
- Meniscus has to be sucked back and restored
- ✓ Speed is of essence
- → For low viscosity, all of the three methods are too slow and too indirect.











Structured coating – new concepts for low viscosity liquids

Two new concepts allow to interrupt and restore the meniscus much faster:

- ✓ Double chamber slot die with modified chamber geometry and Piezo driven suck back pump
- ✓ Switching lip slot die with a Piezo driven lip opening mechanism that sucks back the meniscus right where it is

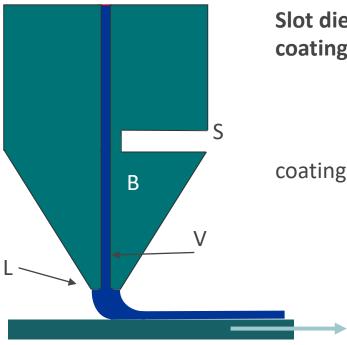








Structured coating – the switching slot die lip



Slot die with movable lips: coating mode

coating works as usual

L lip

V slot volume

B bendable lip

6 bending slot

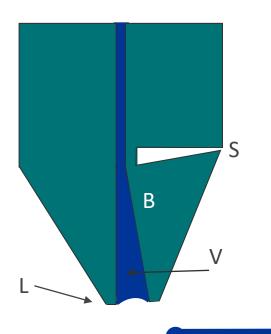








Structured coating – the switching slot die lip



Slot die with movable lips: stop mode

Bendable lip B flips open

Volume V increases and sucks away the meniscus

L lip

V slot volume

B bendable lip

S bending slot

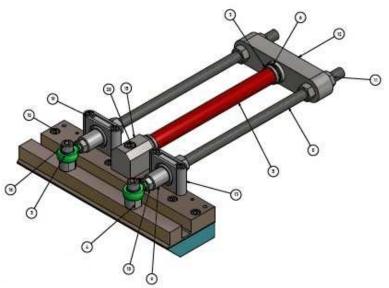








Structured coating – technical implementation with Piezo-Drive

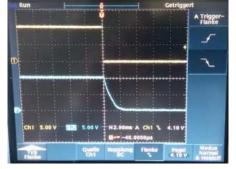


Extremely fast action: within few ms from coating to stop mode and vice versa

Control Voltage

Piezo Response

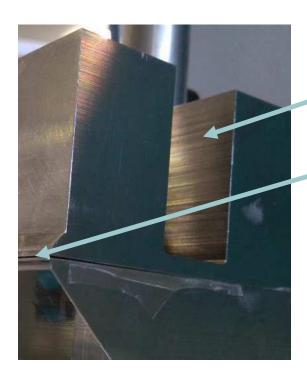




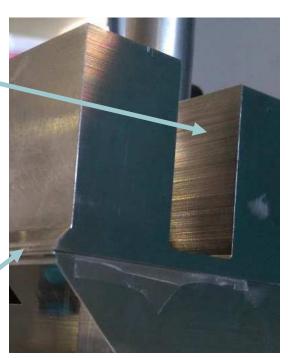




Structured coating – technical implementation with bendable lips



Bending slot Lips open **Difference** is 300 µm only Lips closed



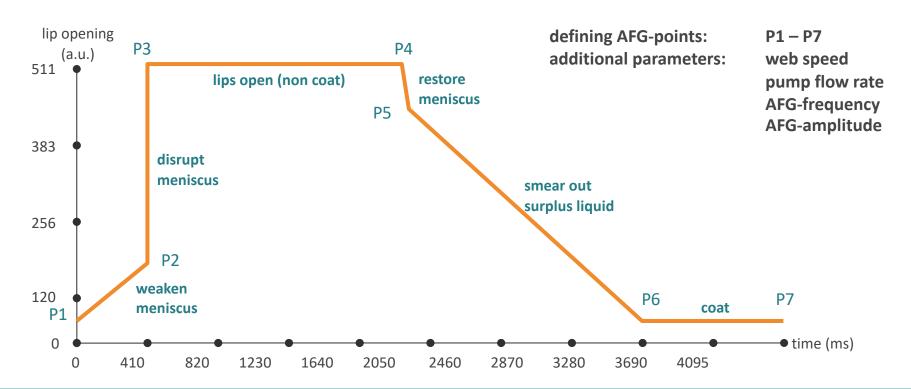


Technical implementation with bendable lips in action





Structured coating – stages of lip motion











Structured coating – ongoing trials: stripe coating of fuel cell paste



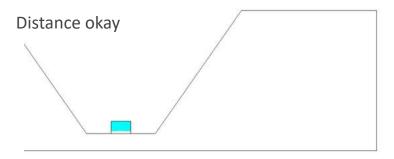


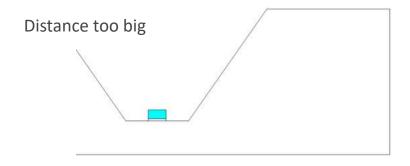
Simulation services at Coatema



Simulation of anode Coating with slot die

- Example for anode electrode coating
- ✓ Fluid data taken from real world (shear-thinning power law fluid)
- ✓ Process parameters for 90 m/min 400 µm coating and 300 mm width
- ✓ No "fancy" slot-die "just" Coatema standard







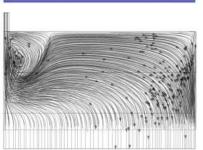
Streamlines and pressure distribution in the slot die

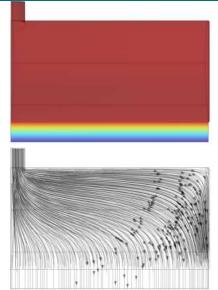
Single Chamber with too small Single Chamber with correct inlet (4 mm)

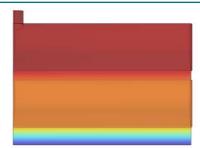
chamber layout (10 mm inlet)

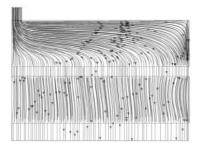
Dual chamber slot die (8 mm inlet same dead volume)







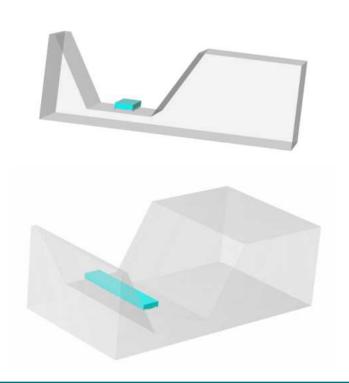


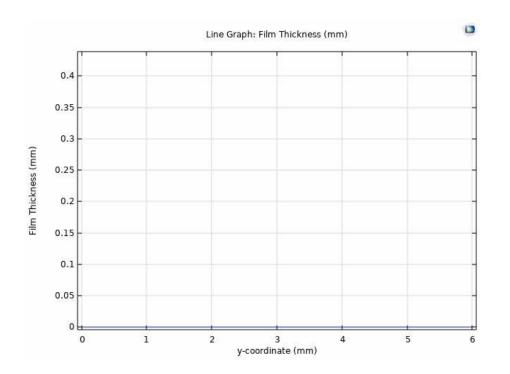


Simulation services at Coatema



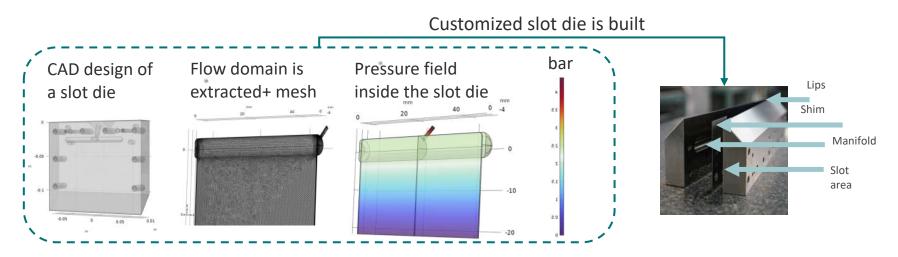
Meniscus makes or breaks Homogeneity







Design of an inner manifold, slot die



Undergoes parameter sweep and iterative design changes to achieve optimal performance for the specific fluid

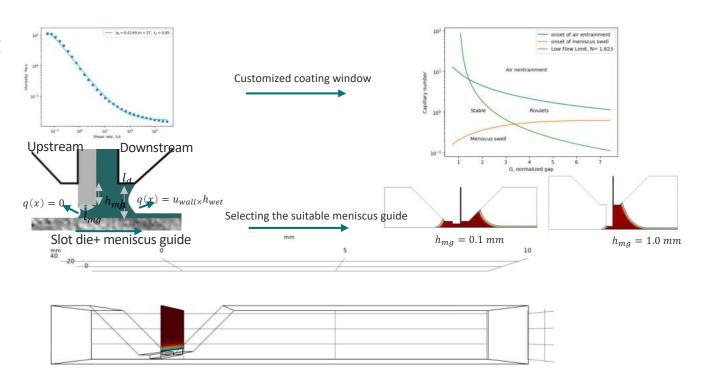
- **Goal:** ✓ Uniform Coating Thickness for the specific fluid
 - ✓ Design the die to handle variations in pressure, especially in cases where the complex fluid exhibits non-Newtonian behavior.

Simulation services at Coatema



Coating process optimization

- ✓ Shear thinning
- ✓ Yield stress



6.

Printing processes



Printing processes



Printing parameters

Printing method	Printing speed (m/s)	Nip pressure (MPa)	Ink viscosity (Pas)	Layer thickness (µm)	Feature size (μm)	Registration (μm)
Flexography	3 – 10	0.1 – 0,5	0.01 – 0.5	0.04 – 8	40 – 80	20 – 200
Gravure	10 – 16	1.5 – 5	0.01 - 0.2	0.1 – 12	20 – 75	>10
Offset	8 – 15	0.8 – 2	1-100	0.5 – 3	25 – 50	>10
Screen printing	2	_	0.1 – 50	3 – 100	75 – 100	>25
Inkjet	1-5	_	0.001 - 0.03	0.01 – 0.5	10 – 50	<10
				20 (UV)		



Printing parameters



Gravure printing





Flexo printing





Screen printing





Inkjet printing





Inkjet printing

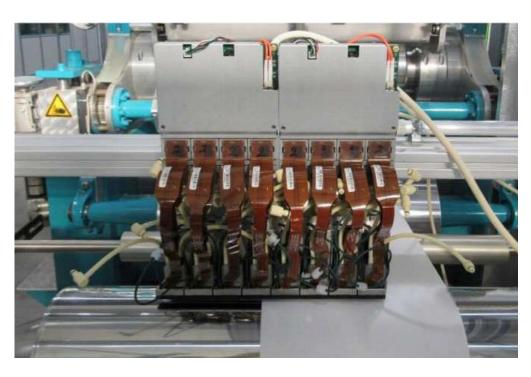




Printing processes



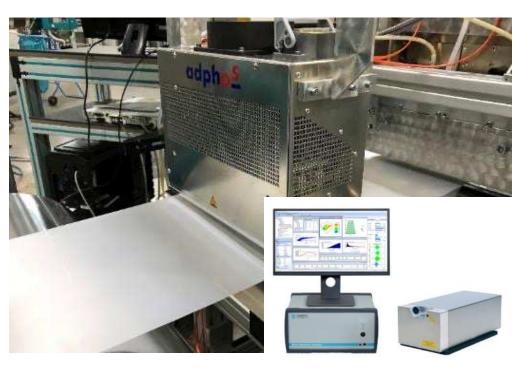
Integration of the "inking" system – current status



- ✓ Printing head and mounting (Fujifilm Dimatix Samba)
- ✓ Fluid recirculation system
- ✓ Power supply
- ✓ Computer



Integration of analysis and sintering units – current status



- ✓ Dantex dynamics "dropwatching"
- ✓ Velocity
- ✓ Size
- ✓ Sphericity
- ✓ Drying / Sintering
- ✓ Adphos NIR
- ✓ IR lamp
- ✓ Photonic sintering
- ✓ Hot air dryer

Printing processes



Integration into new and existing platforms

- ✓ Combination of print heads with high precision granit stone
- ✓ Several sintering methods possible
 - ✓ Hot air dryer to remove solvents (LEL)
 - ✓ NIR / IR / Photonic sintering for conductivity
- ✓ Droplet analysis
- ✓ Possibility to combine inkjet with NIL



Integration – machine layout





Integration – machine layout



Printing processes



Integration – machine layout



Printing processes

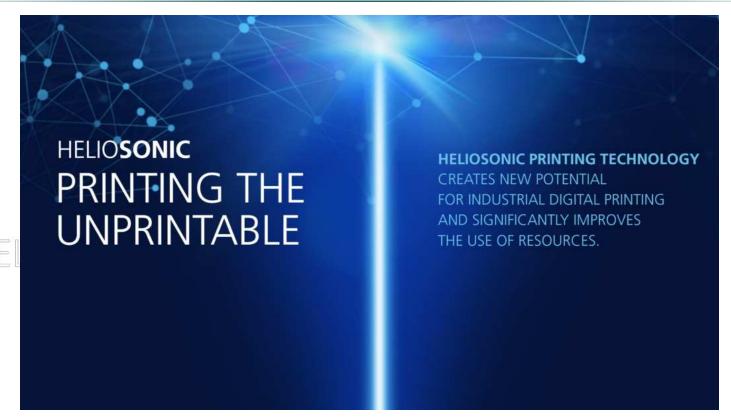


Summary

- ✓ Inkjet provides a step towards a more flexible and customizable production
- ✓ Inkjet is successfully integrated in a R2R process on 300 mm width
- ✓ Width is scalable
- ✓ Speeds up to 10 m/min were tested
- ✓ Different curing / drying systems were tested
- ✓ A layout for a inkjet dedicated machine is available.



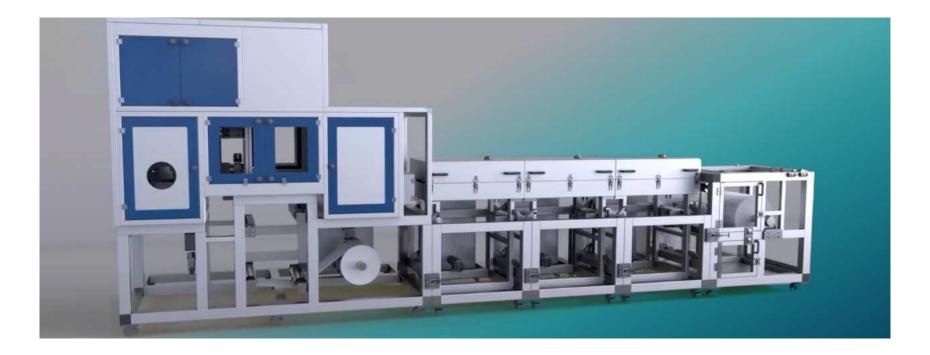








Fuelcell2print – Heliosonic@Coatema







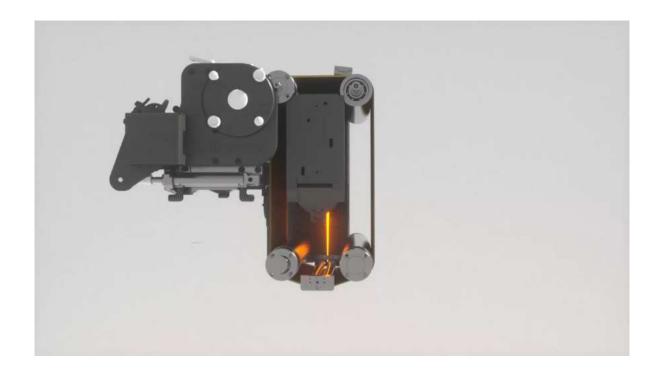
Fuelcell2print – How the technology works







The printhead









Ink recirculation

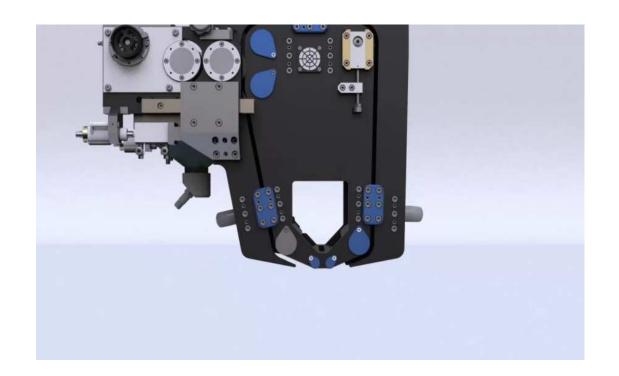








Droplet generation

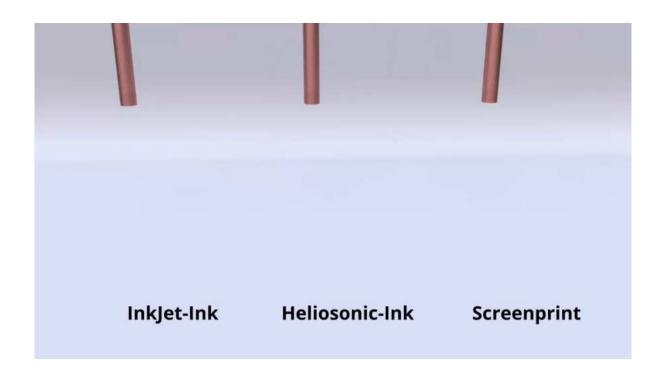








Viscosity range

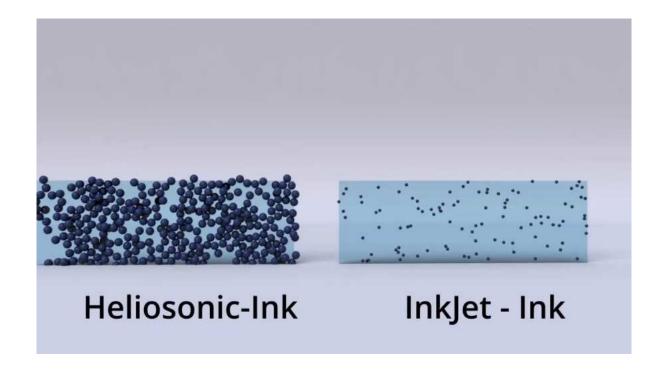








Solids Comparison

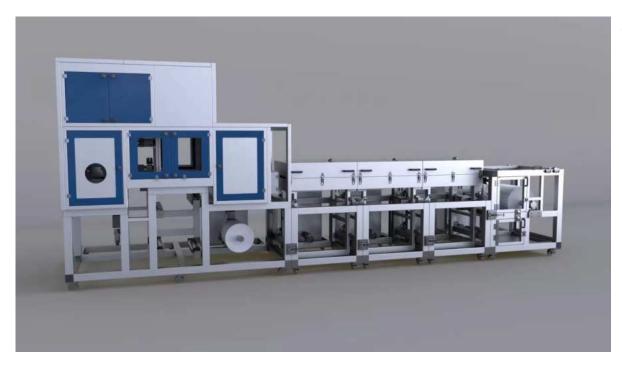








The future production line



Single Printhead

Print width: 180 mm

Print speed: 2 – 10 m/min

Resolution: up to 600 dpi

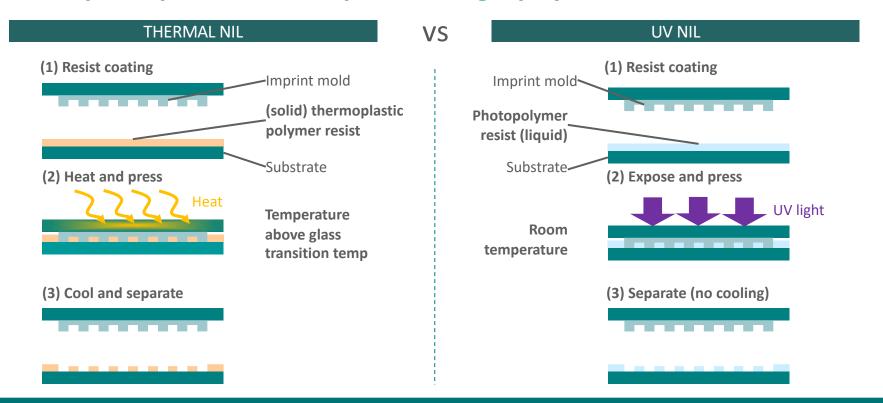
ALTANA

Nanoimprint



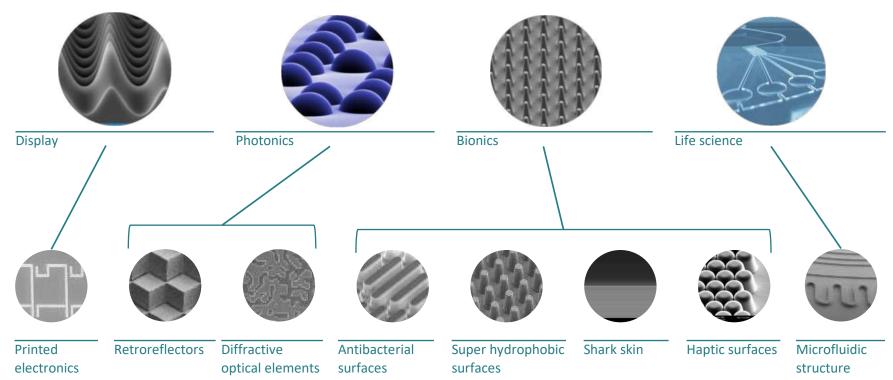


Basic principle of nanoimprint lithography



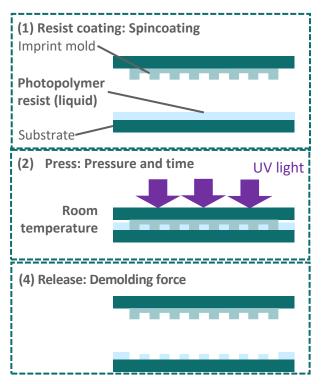


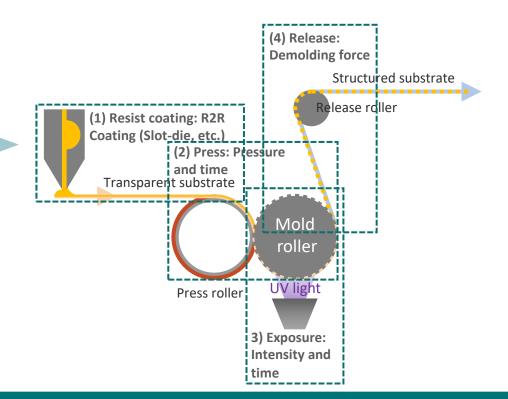
Applications



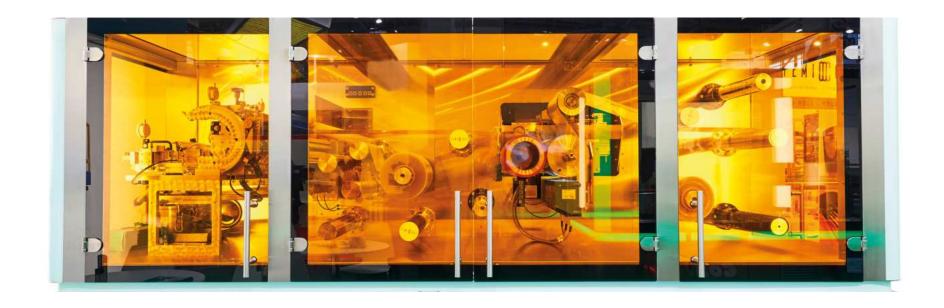


Translating from P2P to R2R

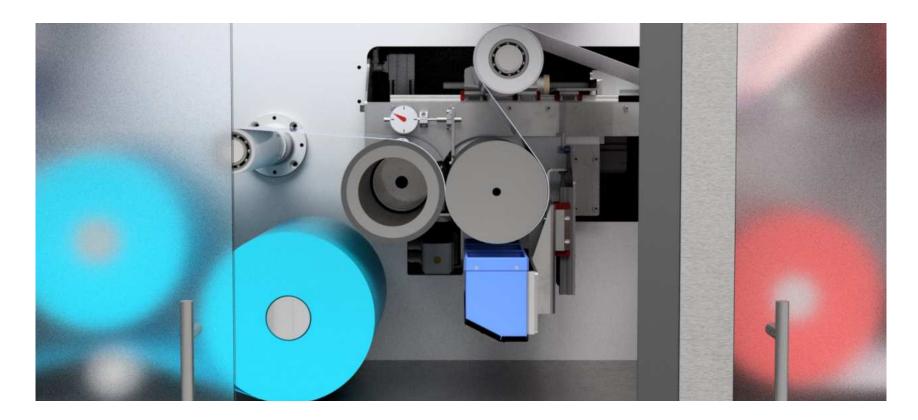














R2R UV-NIL Equipment



Test Solution S2S



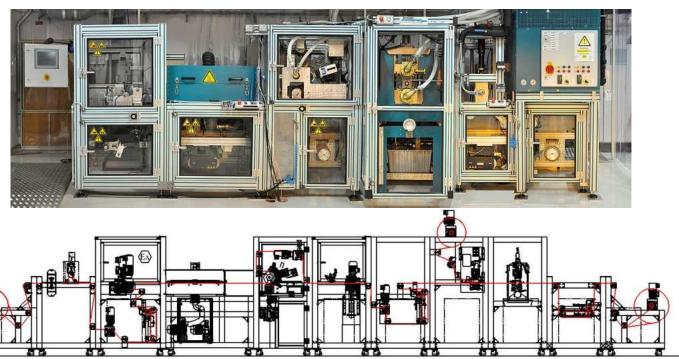
Test Solution R2R





Equipment







Equipment

- ✓ Rollimprint Production Line (Roll-to-Roll, Roll-to-Plate)
- ✓ Films up to 1.0m width, panels up to 1.0m x 1.6m
- ✓ Cleanroom class ISO 5









Equipment

R2R + R2P-Machine

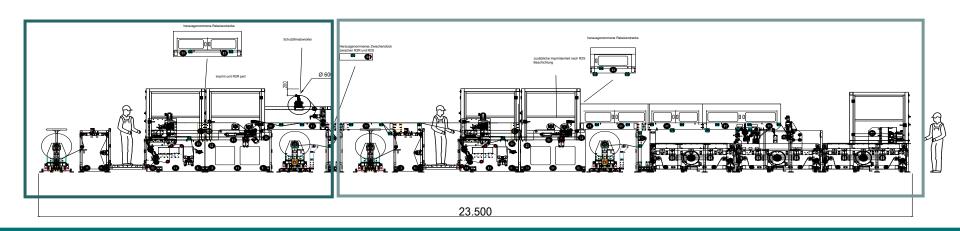
Specs:

Working width R2R: 1100 mm

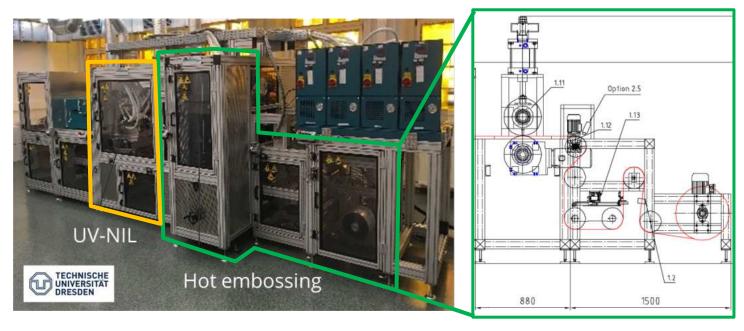
Dimensions R2P: 1000 mm x 1600 mm

Speeds: 6 - 60 m/min

Coating Unit: Slot die coating







Coatema UV-NIL and Hot embossing in one unit

Hot embossing parameters:

Pressure up to 6bar, Temp. up to 170°C, web speed up to 50 m/min, foils up to 250 mm in width

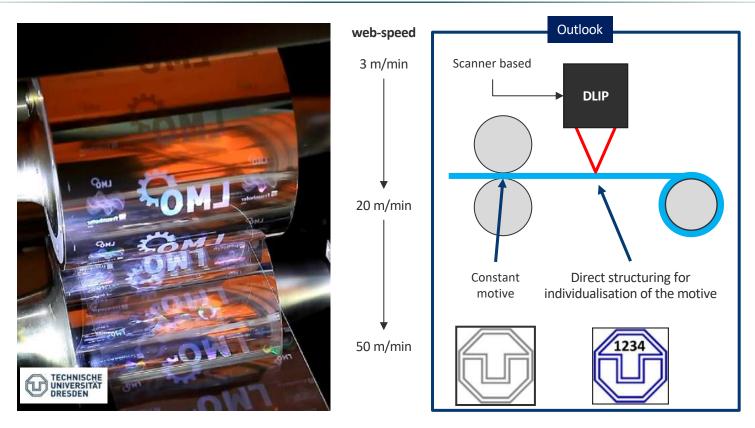






Rank, A., Lang, V. & Lasagni, A. F. High-Speed Roll-to-Roll Hot Embossing of Micrometer and Sub Micrometer Structures Using Seamless Direct Laser Interference Patterning Treated Sleeves. *Adv. Eng. Mater.* **19**, 1–8 (2017).













- √ 500 mm working width & 100 m/min
- ✓ 9m high performance Drying (Convection + IR)
- ✓ Multi Coating Unit
- ✓ Turret-winder for continuous production
- ✓ 200kN/m imprint pressure





State of the art UV-NIL technology / machinery

R2R

NIL 300 R2R







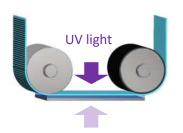


Processes on nontransparent substrates



NIL 300 R2P







PEP

Seamless patterning of large (non-transparent) samples with a small stamp





Design concept – high precision R2P S&R tool for UV-NIL

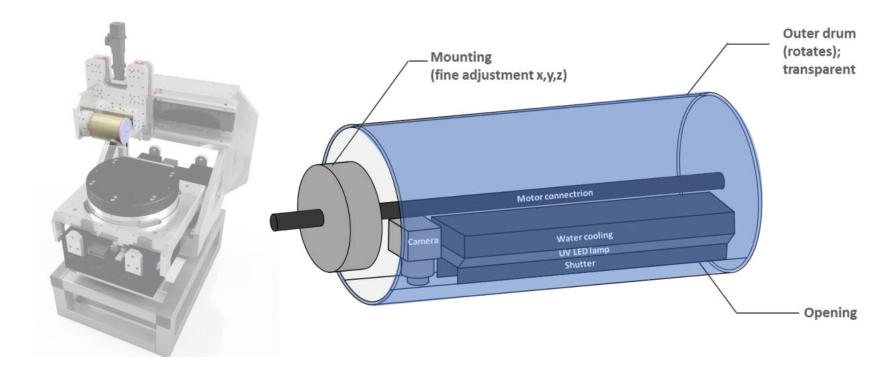


- ✓ R2P Vacuum table for samples up to 300 x 300 mm²
- ✓ Granite base and vacuum table with 1 µm precision
- ✓ Magnetic linear drives + air gearings + interpolated high resolution linear encoders (resolution in <500 nm in xy and ±60 mas Rotation)</p>
- ✓ Dust free housing with constant temperature
- ✓ Transparent acrylic based imprint roller with sub µm flatness
 - ✓ Integrated high power UV LED-lamp
 - Integrated interferometric high resolution camera system





Design concept – high precision R2P S&R tool for UV-NIL







SOLID: Innovative solid-state batteries based on sol-gel materials with Li-metal anode and implemented 3D structuring

- ✓ R2R manufacturing of solid-state thin film batteries
- ✓ Innovative cell concepts
 - ✓ Implementation of a lithium metal anode
 - ✓ Sol-gel cathode and electrolyte
 - ✓ 3D patterning of battery layers



Interface

 $Li_{1+x}Al_xTi_{2-x}(PO_4)_3$

Interface

LiMn₂O₄

Interface

Steel foil

Partners:











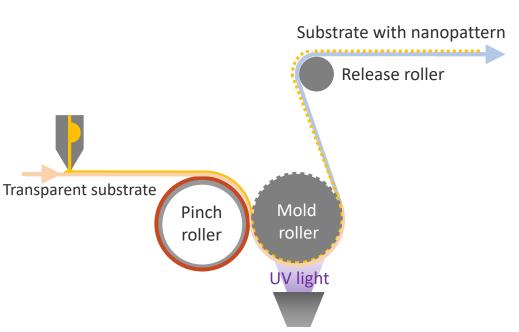
Funding:

FKZ: 03XP0129C

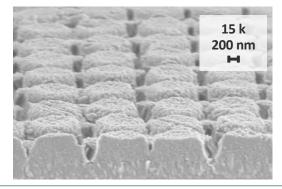




Upscaling of the UV-nanoimprint process



- ✓ Transfer from lab scale R2P→ pilot scale R2R process
- ✓ Feature size 300 nm 1 µm

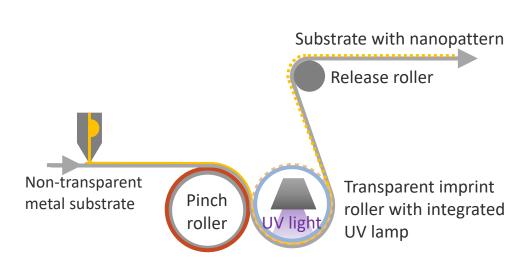


Reference sample prepared using nanoimprint lithography (Fraunhofer ISE)



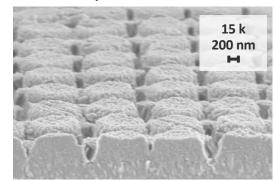


Upscaling of the UV-nanoimprint process



✓ Implementation of a transparent imprint roller on 500 mm working width

- ✓ Transfer from lab scale R2P→ pilot scale R2R process
- ✓ Feature size 300 nm 1 µm
- ✓ Process must be suitable for non-transparent substrates

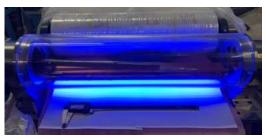


Reference sample prepared using nanoimprint lithography (Fraunhofer ISE)





Upscaling of the UV-nanoimprint process



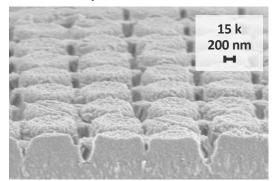




Design concept of the Click&Coat™ module with the transparent imprint roller

- ✓ Implementation of a transparent imprint roller on 500 mm working width
- ✓ Integration into the modular Click&Coat[™] pilot line

- ✓ Transfer from lab scale R2P→ pilot scale R2R process
- ✓ Feature size 300 nm 1 µm
- ✓ Process must be suitable for non-transparent substrates



Reference sample prepared using nanoimprint lithography (Fraunhofer ISE)

8.

Drying technologies





Introduction thermal drying – Coating parameters

Coating chemistry	Coating processes	Process control	Drying
 ✓ Rheology ✓ Viscosity ✓ Viscoelasticity ✓ Type of solvents ✓ Solid content ✓ Van der Waals force ✓ Sheer ratio ✓ Adhesion/Cohesion 	 ✓ Coating systems ✓ Single or multilayer coatings ✓ Direct coatings ✓ Transfer (indirect) coatings ✓ Substrate speed ✓ Layer thickness ✓ Coating accuracy 	 Process layout Tension control system Material guiding system Inline parameter control Quality control 	 Convection drying Contact drying Infrared drying Sintering NIR High frequency UV crosslinking systems
Substrate	Pretreatment	Environment	Finishing
 ✓ Surface tension ✓ Dimension stability ✓ Surface structure ✓ Contact angle 	✓ Corona✓ Plasma✓ Cleaning	HumidityTemperatureInert conditions	CalendaringEmbossingSlitting



Dryer specs needed for the layout

Information about the substrate

- ✓ Web weight weight per unit area
- ✓ Web material
- ✓ Specific heat of web
- ✓ Temperature limitations
- ✓ Operating web tension tension sensitivity
- ✓ Special characteristics

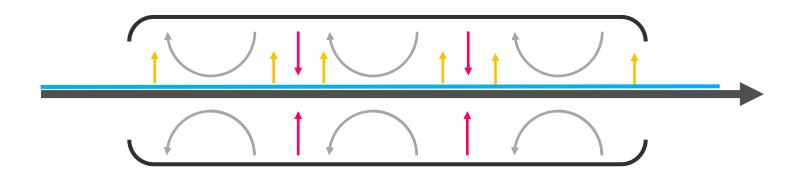


The Click&CoatTM in production scale





Introduction thermal drying – As general as possible(!?)



- ✓ Heat Conduction/ Heat Diffusion
- ✓ Heat Convection/ Mass Transfer
- ✓ Radiation

Substrate
Coating
Heat transfer
Evaporating solvent
Solvent vapor transfer

Mass Transfer



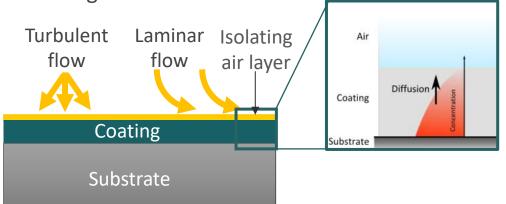
Basics mass + heat transfer - Drying dynamics: The Boundary Layer

An isolating air layer forms just on top of the coated film

✓ Without convection mass+heat transfer is limited to diffusion and therefore slow.

✓ Convective (laminar or turbulent) flow needs to be applied without sacrificing the

coating surface.



Usually there is a trade-off:

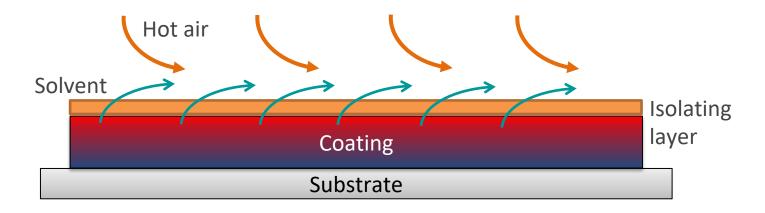
effective fast heat/mass transfer or gentle mild slow drying



Basics mass + heat transfer - Drying dynamics: Hot air drying

- ✓ Heating and vapor transport combined
- ✓ Bulk heating by thermal conductivity from surface
- ✓ Isolating layer to be overcome by air flow

- ✓ High air flow deteriorates surface
- ✓ Temperature easy to limit
- ✓ Slow

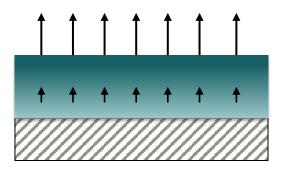




Basics mass + heat transfer

Nothing is as easy as it seems: Diffusion limit and skinning

- ✓ Drying is also limited by solvent diffusion (at least in the final state of low residual solvent content).
- ✓ If the internal diffusion is slower than the evaporation from the surface, then a skin may be created.
- ✓ The skin acts as a barrier. The remaining diffusion through the skin may be slower than the wet diffusion by many orders of magnitude.



So the initial evaporation must be reduced by low temperature and/or by partially saturated atmosphere. Despite reduced evaporation the total drying time then may be shorter than at full initial evaporation.



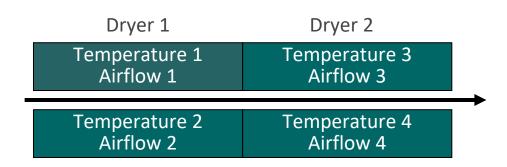
Basics mass + heat transfer - Drying dynamics: Drying zone design

- ✓ Downweb temperature profiles can be realized by partitioning the dryer in different zones with different drying parameters.
- ✓ But temperature uniformity is difficult.
 Possible cause: Mixing of hot and cool air at unintended leakages by Venturi effect.
- ✓ Experience shows, that there is always a compromise:

 Good temperature uniformity
 requires low homogeneous air
 flow. High air flow results in
 less temperature uniformity.

 Dryer 1

 Temperature Airflow 1





Industrial drying systems





Industrial drying systems

Coatema slot nozel and circulation dryer on small scale





Industrial drying systems





Industrial drying systems





Industrial drying systems



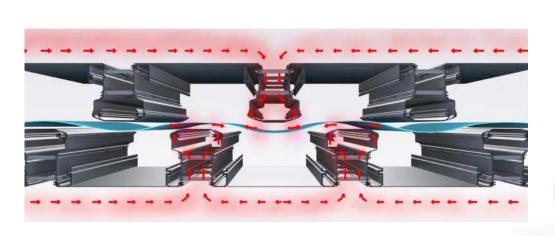


Flotation Click&CoatTM dryer prinziple





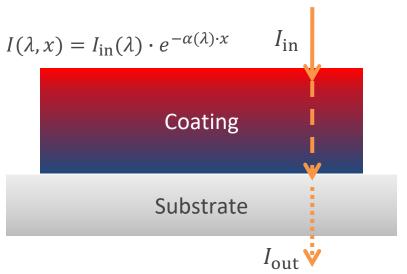
Drytec Click&CoatTM dryer prinziple



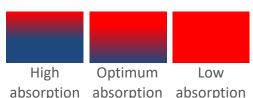


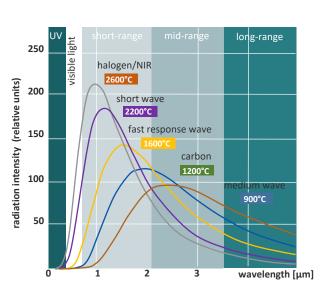


Basics mass + heat transfer: (N)IR technology



 I_{in} (λ) Intensity in I_{out} Intensity out $\alpha(\lambda)$ Absorption coefficient d Layer thickness



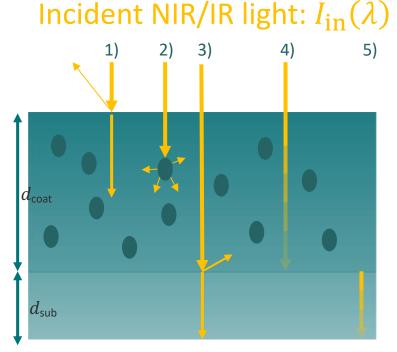


Relative intensity of radiators at different wavelengths



Light-Structure interaction

- 1)Surface reflection R
- 2) Solute absorption α and scattering ϵ
- 3) Internal reflection R
- 4) Solvent absorption α
- 5) Substrate absorption α



Solute:

 $c(d_{\text{coat}}(t), t), \epsilon(\lambda), d(t)$

Solvent:

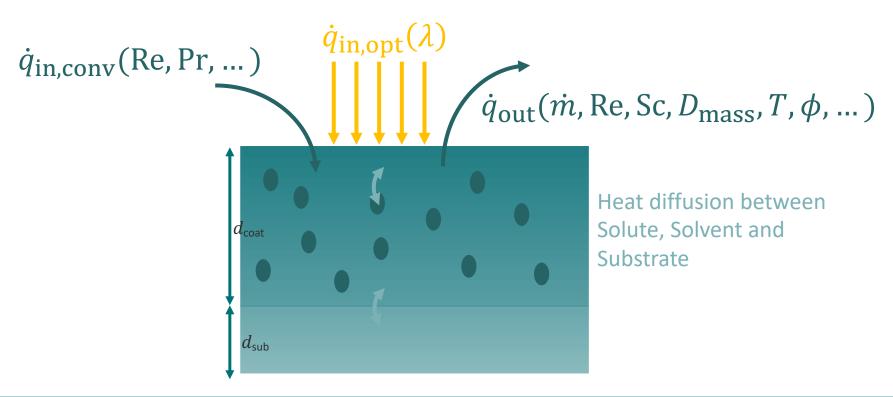
 $R(\lambda), \alpha(\lambda), d(t)$

Substrate:

 $R(\lambda)$, $\alpha(\lambda)$, d_{sub}



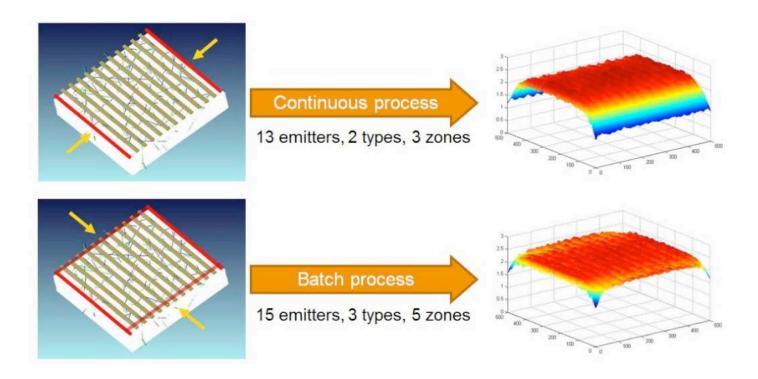
Thermodynamic Model







IR / NIR Drying – Infrared drying

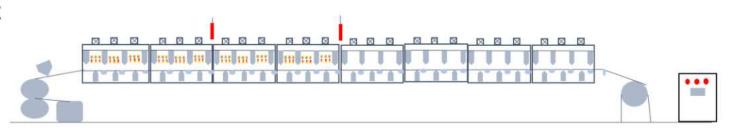


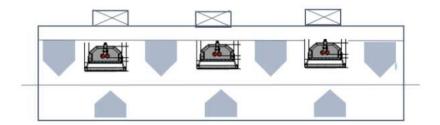




IR / NIR Drying – Infrared drying

Layout





Hotair oven: 50m (10 zone)

IR at first 25m (5 zone) for boost

Heating distance: 100mm

Qty of IR : 60 *3.1Kw = 186Kw

23/05/2024



IR technology – combined hot air / IR dryer in 2010





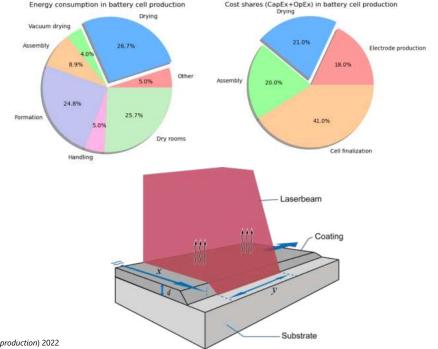






Laser drying of battery slurry

- ✓ Typically, a high-power laser, such as a diode laser o a fiber laser, is used for this purpose
- The laser passing through the optics is directed at a large
- The absorbed laser energy rapidly heats the solvent in the slurry, causing it to evaporate
- ✓ The quick drying might help preventing the formation of cracks or defects in the electrode
- Laser drying is **more energy-efficient** compared to traditional drying
- Laser drying can be adapted for use in highvolume battery manufacturing processes.



[1] Degen et al. (Life cycle assessment of the energy consumption and GHG emissions of state-of-theart automotive battery cell production) 2022 [2] Küpper et al. (The future of battery production for electric vehicles) 2018



Laser drying

Laser System: The laser should be capable of delivering the necessary energy for solvent evaporation without damaging the electrode material.

Temperature Control: Implement temperature control systems within the drying chamber to ensure that the slurry is dried at the suitable temperature.

Gas Atmosphere: Consider the use of inert gases or controlled atmospheres within the drying chamber to prevent unwanted reactions or oxidation of the electrode materials during the drying process.

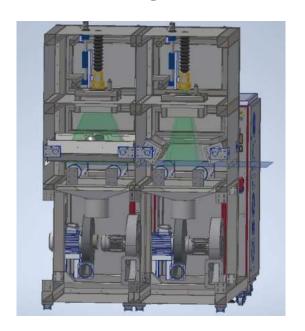
Monitoring and Control: Incorporate sensors and monitoring systems to continuously measure key parameters such as temperature, humidity, and laser power.

Drying Chamber: Design a drying chamber that allows for precise control of temperature, airflow, humidity, etc. to assure a **uniform and efficient drying.**

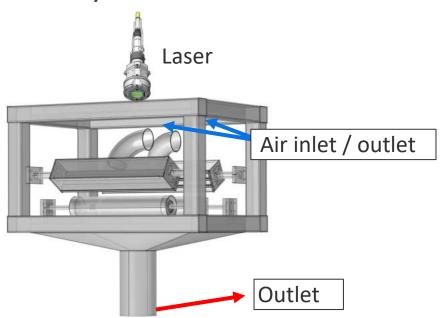


Laser dryer

Coatema's design



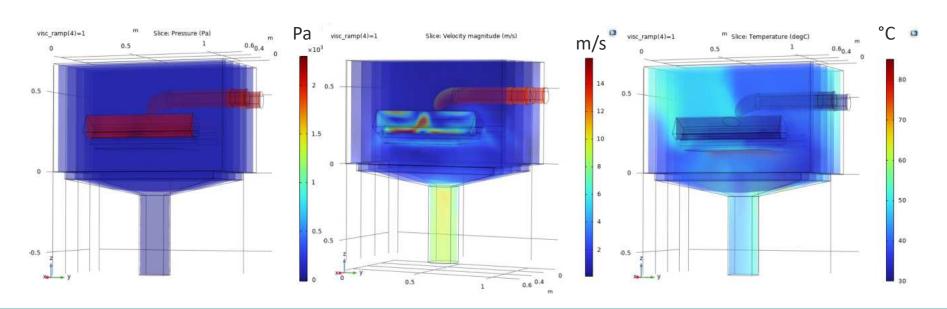
Geometry used for simulation





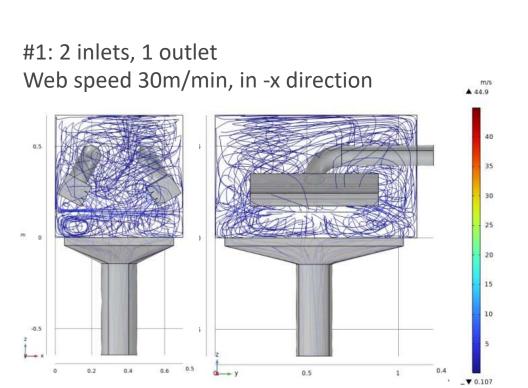
Web speed 30m/min, in -x direction

Pressure Air velocity Temperature

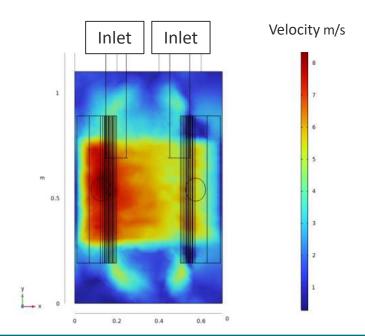




Airflow in 3D, testing different design possibilities



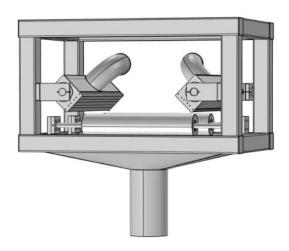
Volumetric air inflow~ 300 m3/hr

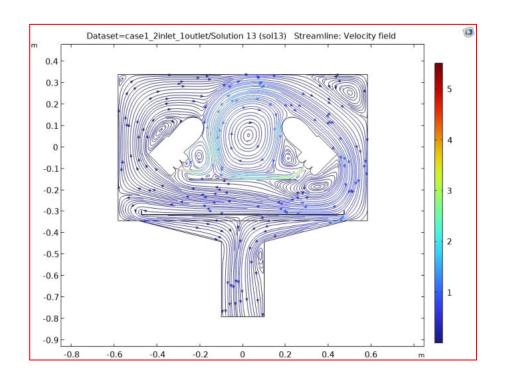




Airflow in 3D, testing different design possibilities

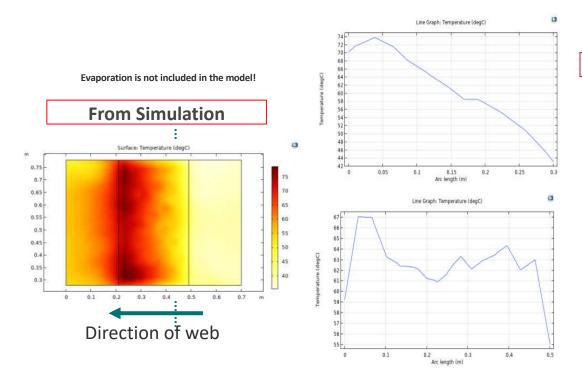
- ✓ The air is blown in a transverse direction to the web
- ✓ 280 mm x 350 mm laser area



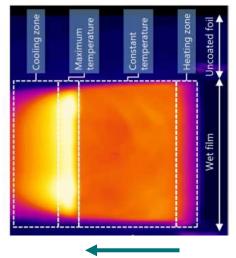




Airflow in 3D, testing different design possibilities



From thermographic camera



Thermographic analysis of the laser drying process

9.

Spatial ALD



Spatial ALD











SALD BV

SALD BV is an Eindhoven (NL) based Spatial ALD-equipment specialist serving the following green growth markets:

- ✓ Li-ion batteries & SSB coatings
- ✓ next-gen thin-film solar (OPV, perovskites)
- fuel-cells and electrolyzers
- Membranes & packaging foils
 - ✓ We have over 10 years industrial experience with Spatial ALD processes.
 - We supply compact Spatial ALD machine for Research and small-scale production
 - ✓ Our technology is scalable from lab-scale up to 24/7 high-volume production



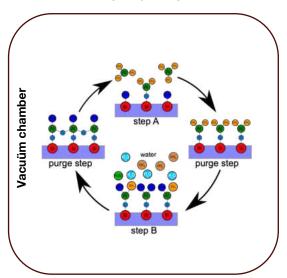


Classic ALD vs. Spatial ALD

Temporal ALD:

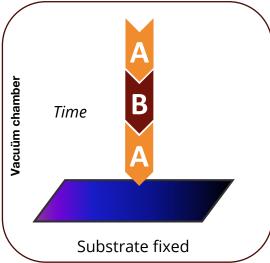
Gas-phase self-limiting deposition process.

One atomic layer per cycle



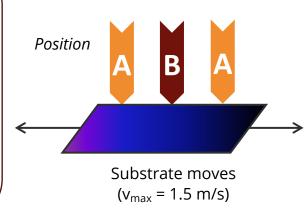
Temporal ALD:

Precursor (A) and co-reactant (B) are **separated in time** in vacuüm



Spatial ALD (SALD):

Precursor (A) and co-reactant (B) are **separated in space** in atmospheric pressure



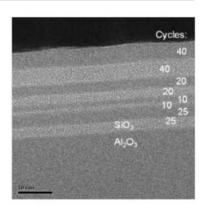




Temporal ALD vs. Spatial ALD & benefits ALD

	Temporal ALD	Spatial ALD (SALD)
Processing	Batch only	In-line / continues / R2R
Atmospheric pressure	No	Yes
Single-sided deposition possible	No	Yes
Typical deposition rate (Al ₂ O ₃)	0.2 nm/min	60 nm/min

- High quality material
- ✓ Precise control in film-thickness
- ✓ Excellent uniformity
- ✓ Wide range of materials such as: metaloxides, metalnitrides, sulfides, fluorides, metals etc.
- ✓ Directly available: Al₂O₃, ZnO, ZnO:Al, SnO₂, TiO₂, SiO₂
- ✓ Low- and high temperature processing possible (50°C 350°C)







Partners in Spatial ALD for Roll-to-Roll production







Spatial ALD for Roll-to-Roll production



Roll-to-Roll spatial ALD solution:

- ✓ 6 nm single pass coating at 60 m/min
- Substrate width on specification
- Demonstrator available from begin of December for demonstration / sampling

Contact us:









In Summary

- ✓ Thermal and Plasma enhanced Spatial ALD concepts for lab and scalable into high volume production
- ✓ SALD is the only company with field experience of Spatial ALD for high volume production
- ✓ Spatial ALD can be integrated in existing high volume production lines
- ✓ SALD has experience with: Al₂O₃, ZnO, ZnO:Al doped, SnO₂, TiO₂ and plasma enhanced SiO₂
- ✓ SALD systems can be equipped with a protective environment like N₂ or Ar.

SALD is an open and flexible company:

- ✓ Open for joint development programs
- Feasibility studies and sampling for new materials and/or applications
- Collaborate to find the best thin-film solution for your application
- Open for investments



10.

Summary



Summary



Bridging the gap

Needed for success:

- ✓ Reproducible results in every step of scale?
- ✓ Reality check if the approach is really scalable?
- ✓ Is the approach an approach for the real life production environment or is it rocket science?
- ✓ Are economies of scale reachable and when?
- ✓ Is durability really needed?
- ✓ Standardization of device manufacturing is the key for the industry
- ✓ Maybe small is the new big?

Coatema research & development centre



Do not hesitate to contact us!



Anything missing?

Let us know and we will make it happen!

Our R&D centre is worldwide the most versatile centre for coating, printing and laminating.

Sales department: sales@coatema.de

Download broschures & presentations

















Thank you

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